

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: KATO, et al.
Application No.: TBD
Filed: March 10, 2004
For: VACUUM PROCESSING APPARATUS AND OPERATING
METHOD THEREFOR
Expected
Group Art Unit: 3749
Expected
Examiner: P. Wilson

PRELIMINARY AMENDMENT

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

March 10, 2004

Sir:

Please amend the above-identified application, prior to examination thereof,
as listed in the following and as set forth on the following pages:

Amendments to the Specification;

Remarks are included following the amendments.